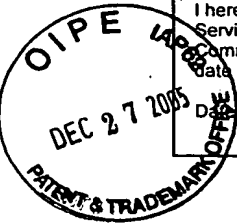


Ifw

Application No.: 10/748,721

Docket No.: 29936/39851



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(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ihl Hyun Cho

Application No.: 10/748,721

Confirmation No.: 7533

Filed: December 30, 2003

Art Unit: 1762

For: METHOD OF FORMING METAL LINE OF
SEMICONDUCTOR DEVICE

Examiner: Nicholas J. Tobergte

AMENDMENT "A"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Amendments to the Claims section (including a complete listing of claims) begins on page 2 of this paper.

The Remarks section begins on page 4 of this paper.